

1 Inventor: Dan G. Custer et al.

2 Title: Polishing Systems, Method of Polishing Substrates, and Methods
3 of Preparing Liquids for Semiconductor Fabrication Processes 3/30/00

4 Assignee: Micron Technology, Inc.

5 Serial No.: 09/298,160

6 Filing Date: April 22, 1999



7 **SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

8 **PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98**

9 In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is
10 directed to the United States patents listed on the attached Form PTO-1449,
11 and copies of which are attached. No admission is made regarding whether
12 all the submitted references are prior art.

13 Citation of these references is respectfully requested.

14 Respectfully submitted,

15
16 Dated: 2/25/00

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TRANSMITTAL FORM (to be used for all correspondence after initial filing)	Application Number	09/298,160	
	Filing Date	April 22, 1999	
	First Named Inventor	Dan G. Custer	
	Group Art Unit	1763	
	Examiner Name	Unknown	
Total Number of Pages in This Submission	3	Attorney Docket Number	MI22-1172

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Firm or Individual name	David G. Latwesen, Ph.D., Reg. No. 38,533
Signature	<i>[Signature]</i>
Date	2/25/00

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